PALM INTRANET

Day: Thursday Date: 3/17/2005

Time: 15:06:42

Inventor Name Search Result

Your Search was:

Last Name = OZGUR First Name = MEHMET

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08709407	5890268			METHOD OF FORMING CLOSED CELL METAL COMPOSITES	OZGUR, MEHMET
09980493	6709739	150	06/24/2002	CLOSED CELL METAL COMPOSITES	OZGUR, MEHMET
10147300	6800912	150	05/17/2002 ,	INTEGRATED ELECTROMECHANICAL SWITCH AND TUNABLE CAPACITOR AND METHOD OF MAKING THE SAME	OZGUR, MEHMET
10147907	6815739	150	05/20/2002	RADIO FREQUENCY MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	OZGUR, MEHMET
10208193	Not Issued	041	07/31/2002	ELECTROMECHANICAL SWITCH AND METHOD OF FABRICATION	OZGUR, MEHMET
10218902	Not Issued	061	08/15/2002	METHOD FOR MAKING CMOS- BASED MONOLITHIC MICRO ELECTROMECHANICAL SYSTEM (MEMS) INTEGRATED CIRCUITS AND INTEGRATED CIRCUITS MADE THEREBY	OZGUR, MEHMET
10462811	Not Issued	041	06/17/2003	MICRO-MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	OZGUR, MEHMET
10663983	Not Issued	092		METHOD OF MAKING AN INTEGRATED ELECTROMECHANICAL SWITCH AND TUNABLE CAPACITOR	OZGUR, MEHMET
10663986	Not Issued	030		METHOD OF FABRICATING RADIO FREQUENCY MICROELECTROMECHANICAL	OZGUR, MEHMET

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			ı	SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	
10835590	Not Issued	030	04/30/2004	PHASED ARRAY ANTENNA USING (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	OZGUR, MEHMET
10929446	Not Issued	030	08/31/2004	MICRO-MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE ´	OZGUR, MEHMET
<u>11009706</u>	Not Issued	030	12/13/2004	MICRO-MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	OZGUR, MEHMET
11052302	Not Issued	020	02/08/2005	METHOD OF FABRICATING RADIO FREQUENCY MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	OZGUR, MEHMET
60003512	Not Issued	159	09/07/1995 ,	CLOSED CELL METAL COMPOSITES	OZGUR, MEHMET
60283915	Not Issued	159	04/13/2001	LTCC-BASED MODULAR MEMS PHASED ARRAY FOR LOW COST IMPLEMENTATION	OZGUR, MEHMET
60291423	Not Issued	159		CMOS-BASED MONOLITHIC MEMS TECHNOLOGY FOR MICROWAVE SYSTEMS	OZGUR, MEHMET
60291647	Not Issued	159	05/18/2001	MEMS-BASED PHASED ARRAY ANTENNA	OZGUR, MEHMET
60310223	Not Issued	159	08/07/2001		OZGUR, MEHMET
60312090	Not Issued	159		CMOS-BASED SEMICONDUCTOR FABRICATION METHOD USING MEMS TECHNOLOGY	OZGUR, MEHMET
60313023	Not Issued	159	08/20/2001	CERAMIC-BASED TECHNOLOGY FOR INTEGRATION OF RECONFIGURABLE RF COMPONENTS IN INTELLIGENT RF FRONT-ENDS	OZGUR, MEHMET
60389292	Not Issued	159	06/18/2002	MICRO MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF	OZGUR, MEHMET

,		RELATIVE OR ABSOLUTE	
		PRESSURE	

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PALM INTRANET

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Inventor Name Search Result

Your Search was:

Last Name = HUFF

First Name = MICHAEL

Application# Patent# Status Date Filed Title Inventor Name					
Application#	Patent#	Status	Date Filed	Title	Inventor Name
09726257	6622558	150	11/30/2000	METHOD AND SENSOR FOR DETECTING STRAIN USING SHAPE MEMORY ALLOYS	HUFF, MICHAEL A.
10147907	6815739	150	05/20/2002	RADIO FREQUENCY MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	HUFF, MICHAEL A
10462811	Not Issued	041	06/17/2003	MICRO-MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	HUFF, MICHAEL A.
10663986	Not Issued	030	09/17/2003	METHOD OF FABRICATING RADIO FREQUENCY MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	HUFF, MICHAEL A.
10716866	Not Issued	092		MEMS-BASED VARIABLE CAPACITOR	HUFF, MICHAEL A.
10835590	Not Issued	030	04/30/2004	PHASED ARRAY ANTENNA USING (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	HUFF, MICHAEL A.
<u>10929446</u>	Not Issued	030		MICRO-MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	HUFF, MICHAEL A
<u>11009706</u>	Not	030	12/13/2004	MICRO-MECHANICAL	HUFF,

	Issued			CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	MICHAEL A.
11015721	Not Issued	020	11	FABRICATION OF MOVABLE MICROMECHANICAL COMPONENTS EMPLOYING LOW-COST, HIGH-RESOLUTION REPLICATION TECHNOLOGY METHOD	HUFF, MICHAEL A.
11052302	Not Issued	020	02/08/2005	02/08/2005 METHOD OF FABRICATING RADIO FREQUENCY MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC) SUBSTRATES	
60283324	Not Issued	159	04/13/2001	MEMS OPTICAL CROSSBAR SWITCH	HUFF, MICHAEL A.
60283915	Not Issued	159	04/13/2001	LTCC-BASED MODULAR MEMS PHASED ARRAY FOR LOW COST IMPLEMENTATION	HUFF, MICHAEL A.
60291647	Not Issued	159		MEMS-BASED PHASED ARRAY ANTENNA	HUFF, MICHAEL A.
60313023	Not Issued	159	08/20/2001	CERAMIC-BASED TECHNOLOGY FOR INTEGRATION OF RECONFIGURABLE RF COMPONENTS IN INTELLIGENT RF FRONT-ENDS	HUFF, MICHAEL A.
60389292	Not Issued	159	06/18/2002	MICRO MECHANICAL CAPACITIVE INDUCTIVE SENSOR FOR WIRELESS DETECTION OF RELATIVE OR ABSOLUTE PRESSURE	HUFF, MICHAEL A.
60530260	Not Issued	159		FABRICATION OF MOVABLE MICROMECHANICAL COMPONENTS EMPLOYING LOW-COST HIGH-RESOLUTION REPLICATION TECHNOLOGY METHODS	HUFF, MICHAEL A.
07566997	5142781	150	11	METHOD OF MAKING A MICROVALVE	HUFF, MICHAEL A.
07726073	5164558	150	07/05/1991	MICROMACHINED THRESHOLD PRESSURE SWITCH AND METHOD OF MANUFACTURE	HUFF, MICHAEL A.
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07899260	5238223	150			HUFF, MICHAEL A.
60427584	Not Issued	159	11/20/2002	MEMS-BASED VARIABLE CAPACITOR	HUFF, MICHAEL A:
60543829	Not Issued	159	02/12/2004	1	HUFF, MICHAEL J.
60424113	Not Issued	159		TELEPHONE FIREWALL	HUFF, MICHAEL L
08510589	5644644	150	08/02/1995	FLOW CAMERA FOR LARGE DOCUMENT REPRODUCTIONS HAVING LENS ADJUSTMENT AND DOCUMENT FEED CONTROL MECHANISM	HUFF, MICHAEL R.
<u>06780951</u>	Not Issued	161	09/27/1985	PORTABLE BAR	HUFFMAN, MICHAEL D
06495366	Not Issued	161	05/17/1983	METHOD AND APPARATUS FOR PREPARING SUPPORTING INSERTS FOR FOAM-PADDED ARTICLES	HUFFMAN, MICHAEL H.
08165348	5417344	250	12/13/1993	SECONDARY CONTAINMENT APPARATUS WITH SUPPORT AND CLAMP	HUFFMAN, MICHAEL H.
07702711	D332977	150	05/20/1991		HUFFMAN, MICHAEL L.
08011214	5354081	150	01/29/1993	1	HUFFMAN, MICHAEL L.
08272933	Not Issued	164	07/11/1994	STUNT RIDING TOY	HUFFMAN, MICHAEL L.
10023272	6684854	150	12/14/2001		HUFFMAN, MICHAEL R.
10792169	Not Issued	030	II I	ELECTRONIC UNIT INJECTOR WITH PRESSURE ASSISTED NEEDLE CONTROL	HUFFMAN, MICHAEL R.
<u>10894109</u>	Not Issued	041	07/19/2004	MECHANICALLY ACTUATED, ELECTRONICALLY CONTROLLÉD FUEL INJECTION SYSTEM	HUFFMAN, MICHAEL R.
08318068	5419306	150	II	APPARATUS FOR HEATING LIQUIDS	HUFFMAN, MICHAEL T.
60549685	Not Issued	159	03/03/2004	PROCESS FOR THE HIGH RECOVERY EFFICIENCY OF SULFUR FROM AN ACID GAS STREAM ~	HUFFMASTER, MICHAEL A.

60549686	Not Issued	159	11	PROCESS FOR THE HIGH RECOVERY EFFICIENCY OF SULFUR FROM AN ACID GAS STREAM	HUFFMASTER, MICHAEL A.
09140103	6107849	150	11	AUTOMATICALLY COMPENSATED CHARGE PUMP	HUFFORD, MICHAEL
09169304	6058033	150		VOLTAGE TO CURRENT CONVERTER WITH MINIMAL NOISE SENSITIVITY	HUFFORD, MICHAEL
09488660	6331833	150	01/20/2000	HIGHLY LINEAR SIGMA-DELTA MODULATOR HAVING GRACEFUL DEGRADATION OF SIGNAL-TO-NOISE RATIO IN OVERLOAD CONDITION	HUFFORD, MICHAEL M.
60133175	Not Issued	159	05/07/1999	HIGHLY LINEAR SIGMA-DELTA MODULATOR HAVING GRACEFUL DEGRADATION OF SIGNAL-TO-NOISE RATIO IN OVERLOAD CONDITION	HUFFORD, MICHAEL M.
09825533	Not Issued	030	04/02/2001	SYSTEM FOR CLINICAL TRIAL SUBJECT COMPLIANCE	HUFFORD, MICHAEL R
09825534	Not Issued	095	04/02/2001	APPARATUS AND METHOD FOR PREDICTION AND MANAGEMENT OF SUBJECT COMPLIANCE IN CLINICAL RESEARCH	HUFFORD, MICHAEL R
09840730	Not Issued	030		INSTRUMENTATION OF A PAPER DIARY TO CREATE AN OBJECTIVE RECORD OF EVENTS	HUFFORD, MICHAEL R
11002046	Not Issued	020	12/01/2004	APPARATUS AND METHOD FOR PREDICTION AND MANAGEMENT OF SUBJECT COMPLIANCE IN CLINICAL RESEARCH	HUFFORD, MICHAEL R.

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1	BRS	24	("5472539" "5479042" "5644327" "6025767" "6154176" "6195047" "6219254" "6347237" "6456172" "6538312" "6694583" "6738600").pn.	EPO; JPO;	2005/03/17 14:08
2	BRS	2 ·	"20020075651"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:08
3	BRS	2	"20020085334"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:08
4	BRS	2	"20030042567"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:08
5	BRS	2	"20030047799"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:08
6	BRS	2	"20030151476"	IH: D(1 + . D(1 +	2005/03/17 14:10
7	BRS	239	257/275.ccls.	US-PGPUB; USPAT; · EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:10
8	BRS	774	257/415.ccls.	IH: D() • . I D() •	2005/03/17 14:10
9	BRS	367	257/798.ccls.	1H'D(10 .1D(10	2005/03/17 14:10

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10	BRS	915	438/455.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:10
11	BRS	214	438/456.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:11
12	IS&R	684	(361/761).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:11
13	IS&R	217	(361/762).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:11
14	IS&R	234	(361/763).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:11
15	IS&R	166	(361/780).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:12
16	IS&R	105	(361/793).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
17	IS&R	342	(361/794).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
18	IS&R	676	(361/803).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12

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19	IS&R	875	(333/185).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
20	IS&R	909	(333/246).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
21	IS&R	573	(333/247).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
22	IS&R	61	(333/259).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:12
23	IS&R	2996	(343/700MS).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:13
24	IS&R	1638	(336/200).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:13
25	IS&R	1890	(29/830).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:13
26	IS&R	0	(39/832).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:13
27	IS&R	0	(39/846).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:13

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28	IS&R	941	(29/854).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:14
29	IS&R	444	(257/664).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:14
30	IS&R	696	(257/703).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:14
31	IS&R	1190	(257/704).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:15
32	IS&R	1598	(257/724).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:15
33	IS&R	748	(257/728).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:16
34	BRS	17460	microelectromechanical MEMS	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:21
35	BRS	2	S2 and S35		2005/03/17 14:17
36	BRS	0	S3 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17

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37	BRS	1	S4 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
38	BRS	1	S5 and/S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
39	BRS	0		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
40	BRS	2	S7 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
41	BRS	174	S8 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
42	BRS	3	S9 and S35	IN'DITE . 1 DITE	2005/03/17 14:17
43	BRS	107	S10 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
44	BRS	43	S11 and S35	18. PL 1 * . 1 PL 1 *	2005/03/17 14:17
45	BRS	10	S12 and S35	N: D: 1 + . ! D: 1 +	2005/03/17 14:17

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46	BRS	3	S13 and S35		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:17
47	BRS	1	S14 and S35	,		2005/03/17 14:18
48	BRS	0	S15 and S35 ´		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:18
49	BRS	1	S16 and S35		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:18
50	BRS	1	S17 and S35	,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:18
51	BRS	6	S18 and S35		DERWENT; IBM_TDB	2005/03/17 14:18
52	BRS	9	S19 and S35	·	IN: D() • . 1 D() •	2005/03/17 14:18
53	BRS	9	S20 and S35	,	IM: P() + . P() +	2005/03/17 14:18
54	BRS	1	S21 and S35	·	H(D() + . D() +	2005/03/17 14:18

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55	BRS	1	S22 and	s35		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:18
56	BRS	104	S23 and	\$35		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:18
57	BRS	30	S24 and	S35		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:18
58	BRS	8	S25 and	S35 ^	,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:18
59	BRS	0	S26 and	S35		IH: D() • . D() •	2005/03/17 14:18
60	BRS	0	S27 and	S35	,	IH: P() • . P() •	2005/03/17 14:19
61	BRS	1	S28 and	S35 ,		H: P() * . P() *	2005/03/17 14:19
62	BRS	0	S29 and	S35		H: D() * . D() *	2005/03/17 14:19
63	BRS	0	S30 and	S35	,	H: D() • . (D() • .	2005/03/17 14:19

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64	BRS	3	S31 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:19
65	BRS	55	S32 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:19
66	BRS	18	S33 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:19
67	BRS .	4	S34 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:19
68	BRS	11	S1 and'S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:20
69	BRS	1046	low?temperature adj co?fired adj cermic LTCC	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:31
70	BRS	128	S78 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:22
71	BRS	0	S3 and, S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:22
72	BRS	0	S5 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:22

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73	BRS	0	S6 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:22
74	BRS	0	S12 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:23
75	BRS	0	S13 and S79	1H. P() • . 1 P() •	2005/03/17 14:23
76	BRS	0	S14 and S79	IM' DI 1 0 1 1 0 1 1 0	2005/03/17 14:23
77	BRS	0	S15 and S79	JP. P() * . P() *	2005/03/17 14:23
78	BRS	0	S16 and S79	DERWENT; IBM_TDB	2005/03/17 14:23
79	BRS	0	S17 and S79	18. P() * . P() *	2005/03/17 14:23
80	BRS	0	S18 and S79	IH: DI 1 0 . I DI 1 0	2005/03/17 14:23
81	BRS	0	S19 and S79	1H: D() • . 1 D() •	2005/03/17 14:24

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	- -				US-PGPUB;	
82	BRS	0	S20 and S79	,	USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:24
83	BRS	0	S21 and S79	·	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
84	BRS	0	S22 and S79		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
85	BRS	0	S25 and S79		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
86	BRS	0	S26 and S79		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:24
87	BRS	0	S27 and S79	,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB	2005/03/17 14:24
88	BRS	0	S28 and S79		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
89	BRS	0	S29 and S79		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
90	BRS	0	s30 and S79	,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24

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91	BRS	0	S33 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
92	BRS	0	S34 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:24
93	BRS	1	S31 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:25
94	BRS	9	S32 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:25
95	BRS	1	S24 and S79		2005/03/17 14:26
96	BRS	8	S23 and S79	IH. P() + . P() +	2005/03/17 14:26
97	BRS	1	S11 and S79	IH: P() • . P() •	2005/03/17 14:27
98	BRS	1	S10 and S79	IN: D() • . D() •	2005/03/17 14:27
99	BRS	1	S9 and S79	US-PGPUB; USPAT;	2005/03/17 14:27

	Туре	Hits	Search Text	DBs	Time Stamp
100	BRS	3	S8 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:28
101	BRS	1	S7 and S79	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:28
102	BRS	1	S4 and S79	H: D(1 0 1 D() 0	2005/03/17 14:28
103	BRS	1	S2 and S79	IN: DIT + . D(T+:	2005/03/17 14:29
104	BRS	3	S1 and S79	IH: P() • . P() •	2005/03/17 14:29
105	BRS	О	("6815739").URPN.	III C D M'I'	2005/03/17 14:30
106	BRS	16	"6025767" "6154176"	IUS PATE	2005/03/17 14:30
107	BRS	4	S116 and S79	IH: P() • . I P() •	2005/03/17 14:30

	Туре	Hits	Search Text	DBs	Time Stamp
108	BRS	129	(low?temperature adj co?fired	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 14:53
109	BRS	10	(low?temperature adj co?fired adj cermic LTCC) with module and S35	EPO; JPO; DERWENT;	2005/03/17 14:33
110	BRS	83	(low?temperature adj co?fired	USPAT;	2005/03/17 14:54
111	BRS	13.	(low?temperature adj co?fired	USPAT;	2005/03/17 14:55
112	BRS	43	same circuit same (low?temperature adj co?fired adj cermic LTCC) with second	USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:09
113	BRS	9	(low?temperature adj co?fired adj cetmic LTCC) with second	USPAT;	2005/03/17 14:55
114	BRS	22	same (bond bonded bonding) same (low?temperature adj co?fired adj cermic LTCC)	USPAT;	2005/03/17 15:09

	Туре	Hits	, Search Text	DBs	Time Stamp
115	BRS	11	same (bond bonded bonding) same (low?temperature adj co?fired adj cermic LTCC)	US-PGPUB;	2005/03/17 15:09
116	IS&R	1072	(438/107).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:23
117	IS&R	1360	(438/118).CCLS.	16°0714 .10714	2005/03/17 15:24
118	IS&R	802	(438/126).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:24
119	IS&R	862	(438/125).CCLS.	IN' DE 1 . I DE 1 .	2005/03/17 15:24
120	BRS	35	S126 and (microelectromechanical MEMS)	IN'U(10 . IU(10	2005/03/17 15:24
121	BRS	23	S127 and (microelectromechanical MEMS)	1M' LJ() • . 1 LJ() •	2005/03/17 15:25
122	BRS	11	S128 and (microelectromechanical MEMS)	IH: D() • . I D() •	2005/03/17 15:25

	Туре	Hits	Search Text	DBs	Time Stamp
123	BRS	20	S129 and (microelectromechanical MEMS)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:41
124	BRS	2		US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:25
125	BRS	3	corrired adj cermic Lice,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:26
126	BRS	1	S132 and (low?temperature adj co?fired adj cermic LTCC)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:26
127	BRS	3	S133 and (low?temperature adj	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:26
128	BRS	/6	and (low?temperature adj co?fired adj cermic LTCC) and	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:41
129	BRS	42	and (low?temperature adj co?fired adj cermic LTCC) and	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:42
130	BRS	27	<pre>(microelectromechanical MEMS) and (low?temperature adj co?fired adj cermic LTCC) and amplifier</pre>	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:42
131	BRS	7	co?fired adj cermic LTCC) and amplifier and array adj	USPAT;	2005/03/17 15:43

	Туре	Hits	Search Text	DBs	Time Stamp
132	BRS	14	co?fired adj cermic LTCC) and radiating adj (element	USPAT;	2005/03/17 15:44
133	BRS		co?fired adj cermic LTCC) and radiating adj (element	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/03/17 15:44
134	BRS	7	radiating adj (element elements) and array adi	USPAT;	2005/03/17 15:44